

PATENT ASSIGNMENT COVER SHEET

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EPAS ID: PAT3816857

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
GUENTHER KOPPITSCH	10/05/2015
EWALD STUECKLER	09/15/2015
KARL ROHRACHER	09/15/2015
JORDI TEVA	09/19/2015
RECEIVING PARTY DATA	
Name:	AMS AG
Street Address:	SCHLOSS PREMSTAETTEN
Internal Address:	TOBELBADER STR. 30
City:	UNTERPREMSTAETTEN
State/Country:	AUSTRIA
Postal Code:	8141
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	14766412
CORRESPONDENCE DATA	
Fax Number:	(949)851-9348
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
Phone:	949-851-0633
Email:	ltillman@mwe.com, ipdocketmwe@mwe.com
Correspondent Name:	JOHN D. MAGLUYAN
Address Line 1:	MCDERMOTT WILL & EMERY LLP
Address Line 2:	4 PARK PLAZA, SUITE 1700
Address Line 4:	IRVINE, CALIFORNIA 92614-2559
ATTORNEY DOCKET NUMBER:	090922-0418
NAME OF SUBMITTER:	JOHN D. MAGLUYAN, REG. #56,867
SIGNATURE:	/John D. Magluyan/
DATE SIGNED:	04/05/2016
Total Attachments: 8	

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Docket No.: 090922-0418 (P2013,0140 US N)

ASSIGNMENT

In consideration of the premises and other good and valuable consideration in hand paid, the receipt and sufficiency of which is hereby acknowledged, the undersigned,

(1) <u>Guenther KOPPITSCH</u>	(4) <u>Jordi TEVA</u>
(2) <u>Ewald STUECKLER</u>	(5) _____
(3) <u>Karl ROHRACHER</u>	(6) _____

who have made a certain new and useful invention, hereby sell, assign and transfer unto

ams AG

Schloss Premstaetten

Tobelhader Str. 30

8141 Unterpremstaetten

AUSTRIA

and its successors, assigns and legal representatives (hereinafter designated "ASSIGNEE") the entire right, title and interest for the United States of America as defined in 35 U.S.C. 100 in the invention entitled

MASKING METHOD FOR SEMICONDUCTOR DEVICES WITH HIGH SURFACE TOPOGRAPHY

for which an application for United States Letters Patent was filed on August 6, 2015, and identified by United States Application No. 14/766,412;

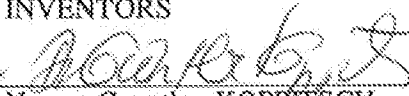
and the undersigned hereby authorize and request the registered practitioners of McDermott Will & Emery LLP to insert the filing date and application number of said application as necessary;

and the undersigned hereby authorize and request the United States Commissioner for Patents and Trademarks to issue any and all United States Letters Patent which may be granted therefor and any and all extensions, divisions, reissues, substitutes, renewals, continuations, continuations-in-part, reviews and re-examinations thereof, and the right to all benefits under the International Convention for the Protection of Industrial Property to said ASSIGNEE, for its interest as ASSIGNEE; the undersigned agree that the attorneys of record in said application shall hereafter act on behalf of said ASSIGNEE;

and the undersigned hereby agree to transfer a like interest, to render all necessary assistance in making application for and obtaining original, extended, divisional, reissued, substituted, renewed, continued, continued-in-part, reviewed and re-examined Letters Patent of the United States, upon request of said ASSIGNEE and without further remuneration, in and to any improvements and applications for patent based thereon, growing out of or related to said invention, and to execute any papers by or for said

ASSIGNEE, deemed essential to ASSIGNEE's full protection and title in and to the invention hereby transferred.

SIGNED on the dates indicated aside our signatures:

	INVENTORS	DATE SIGNED
1)	 Name: Guenther KOPPITSCH	5.10.2015
2)	_____ Name: Ewald STUECKLER	_____
3)	_____ Name: Karl ROHRACHER	_____
4)	_____ Name: Jordi TEVA	_____
5)	_____ Name:	_____
6)	_____ Name:	_____

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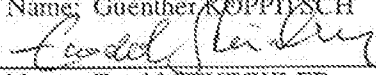
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	INVENTORS	DATE SIGNED
1)	Name: Guenther KOPPIESCH	
2)	 Name: Ewald STUECKLER	September 15, 2015
3)	Name: Karl ROHRACHER	
4)	Name: Jordi TEVA	
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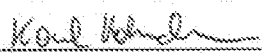
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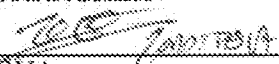
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1)	Name: Guenther KOPPITSCH	
2)	Name: Ewald STUECKLER	
3)	Name: Karl ROHRACHER	
4)	 Name: Jordi TEVA	19. September 2015
5)	Name:	
6)	Name:	